ABSTRACT

A method of manufacturing a disk-shaped substrate includes: a step of disposing a carrier, which accommodates a disk-shaped substrate, between a lower surface plate and an upper surface plate; a step of sandwiching the disk-shaped substrate between the lower surface plate and the upper surface plate and subjecting the disk-shaped substrate to a polishing treatment while supplying a treatment liquid between the lower surface plate and the upper surface plate; a step of supplying a first separation fluid, which separates the disk-shaped substrate from the upper surface plate, between the upper surface plate and the disk-shaped substrate, using a first supply system; and a step of supplying a second separation fluid, which separates the carrier from the upper surface plate, between the upper surface plate and the carrier, using a second supply system independent of the first supply system.

[FIG. 2]